24th International Conference on Vacuum Technique and Technology (VTT 2017)

Journal of Physics: Conference Series Volume 872

St. Petersburg, Russia 6 – 8 June 2017

ISBN: 978-1-5108-4424-7

ISSN: 1742-6588

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Accepted papers received: 30 June 2017

Published online: 10 July 2017

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